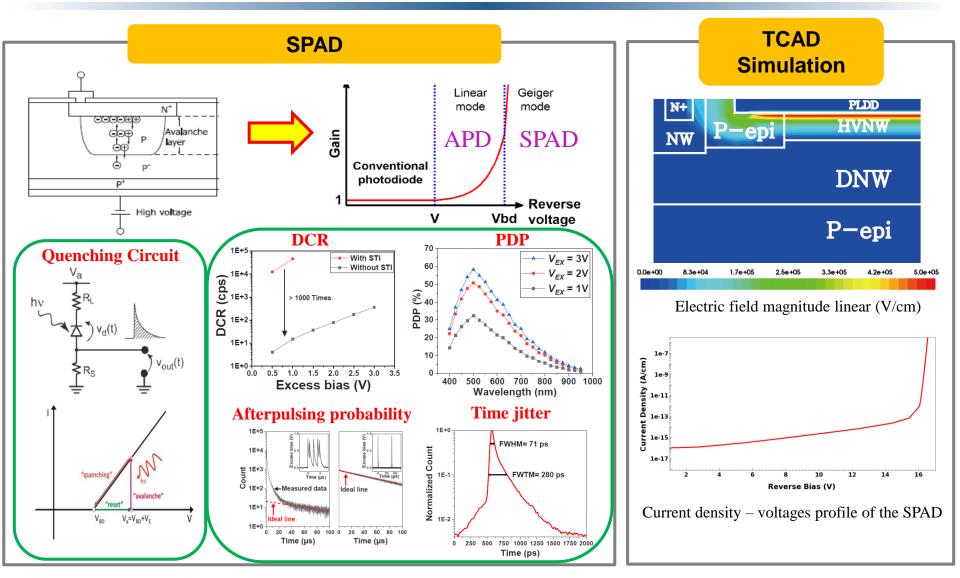
2020-2~2022-1 Works



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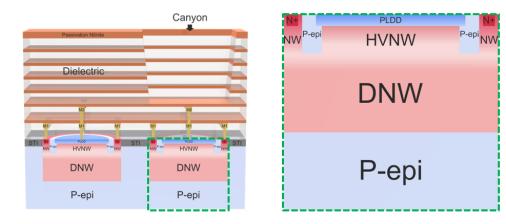


Publication

P+ STI N+ STI (a) P-epi & STI P-epiNW PW STI N+ DNW DNW P-epi P-epi P+ STI (b) P-epi ST P-epiNW PW DNW DNW P-epi P-epi

<Accepted>

<Submitted>



Won-Yong Ha et al. "Noise optimization of single-photon avalanche diodes fabricated in 110 nm CMOS image sensor technology", *Optics Express (Editors' Pick)* Won-Yong Ha et al. "SPAD Developed in 55 nm BCD Technology Achieving Near 90% Peak PDP", *IEDM*



2022 Plan





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